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c901 U.S. PTO

08-28-00

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Docket No. 4215/PDD/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Re: Inventor(s): Lizhong Sun, Shijian Li, Fred C. Redeker
Title: CU CMP POLISHING PAD CLEANING

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 15 pages.
☒ Drawings totaling pages, Formal 2 Informal.
☒ Executed Declaration and Power of Attorney.
☒ Assignment of the invention to Applied Materials, Inc.
☒ Assignment Recordation Cover Sheet

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09/645690
08/24/00

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	-25-	- 20 =	-5-	X \$22.00	-\$110.00-
Independent Claims	-3-	- 3 =	-0-	X \$82.00	-0-
Basic Filing Fee				\$690.00	\$690.00
TOTAL FEES					\$800.00

- ☒ The Commissioner is hereby authorized to charge \$800.00 to Deposit Account No. 50-1074
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
☒ Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052

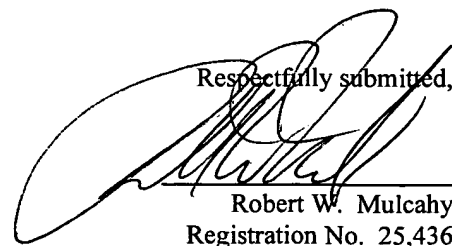
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

Express Mail Receipt No. E435691511345

Date of Deposit 8-24-2000

Signature Ben Mulcahy

Respectfully submitted,


Robert W. Mulcahy
Registration No. 25,436